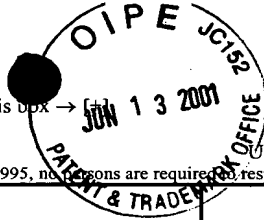


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INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Application Number	09/803,983
				Filing Date	March 13, 2001
				First Named Inventor	Kojo KAKIZAKI et al.
				Group Art Unit	2881
				Examiner Name	Unknown
Sheet	1	of	1	Attorney Docket Number	740145-195

U.S. PATENT DOCUMENTS						
Examiner Initials ¹	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
		5,856,991		ERSHOV	01-05-1999	

FOREIGN PATENT DOCUMENTS								
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		PERFORMANCE CHARACTERISTICS OF ULTRA-NARROW ArF LASER FOR DUV LITHOGRAPHY, ALEX ERSHOV ET AL., SPIE VOL. 3679, MARCH 1999, PP. 1030-1037	
		HIGH REPETITION RATE EXCIMER LASERS FOR DUV LITHOGRAPHY, U. STAMM ET AL., SPIE VOL. 3679, MARCH 1999, PP. 1050-1057	

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Serial No. 09/803,983

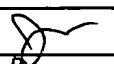


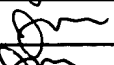

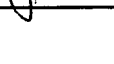
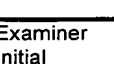
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Applicants: Koji KAKIZAKI

Filing Date: March 13, 2001

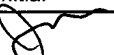
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	1 091 462	04/11/2001	EP			Part Eng
	1 111 744	06/27/2001	EP			Full Eng
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